



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
(Case No. 98,162-B)

In re Application of:)
DeGendt, et al.)
Serial No.: 09/207,546) Group Art Unit: 1746
Filed: December 8, 1998) Examiner: Ahmed
For: METHOD FOR REMOVING ORGANIC)
CONTAMINANTS FROM A)
A SEMICONDUCTOR SURFACE)

Commissioner for Patents
Washington, D.C. 20231

RESPONSE TO OFFICE ACTION DATED NOVEMBER 6, 2001

Dear Sir:

In response to the outstanding Office Action mailed November 6, 2001, please
enter the following remarks in the above-referenced patent application.

REMARKS

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TC 1700

Claim Rejections

In paragraph three of the Office Action, claims 27 and 28 were rejected under 35 U.S.C. §103(a) as being unpatentable over Ilardi et al. (U.S. Patent No. 5,466,389) in view of Kern (Hand Book of Semiconductor wafer cleaning technology) and further in view of Sehested et al. (J.Phys.Chem.). In paragraph five of the Office Action, claims 29-33 and 35 were rejected under 35 U.S.C. §103(a) as being unpatentable over Heyns et al. (New Wet Cleaning Strategies for

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